

Docket No. 99-005  
Express Mail: EM 083176878 US

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

Patent No.: 6,998,625  
Issue Date: February 14, 2006  
Title: Ion Implanter Having Two-Stage Deceleration Beamline  
Assignee: Varian Semiconductor Equipment Associates, Inc.  
Inventors: Charles M. McKenna et al.  
Art Unit: 2881

**STATEMENT UNDER 37 CFR § 1.324(b)(2) REGARDING CHANGE OF INVENTORSHIP**

Sir:

I, **CHARLES M. MCKENNA**, state that I have no disagreement to the requested change of inventorship in adding Manny Sieradzki as an inventor in the above-referenced patent.

Respectfully submitted,

Date: Sept. 14, 2007

By:   
Charles M. McKenna

Docket No. 99-005  
Express Mail: EM 083176878 US

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

Patent No.: 6,998,625  
Issue Date: February 14, 2006  
Title: Ion Implanter Having Two-Stage Deceleration Beamline  
Assignee: Varian Semiconductor Equipment Associates, Inc.  
Inventors: Charles M. McKenna et al.  
Art Unit: 2881

**STATEMENT UNDER 37 CFR § 1.324(b)(2) REGARDING CHANGE OF INVENTORSHIP**

Sir:

I, NICHOLAS R. WHITE, state that I have no disagreement to the requested change of inventorship in adding Manny Sieradzki as an inventor in the above-referenced patent.

Date: 8/30/07

Respectfully submitted,

By: NR White  
Nicholas R. White

Docket No. 99-005  
Express Mail: EM 083176878 US

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

Patent No.: 6,998,625  
Issue Date: February 14, 2006  
Title: Ion Implanter Having Two-Stage Deceleration Beamline  
Assignee: Varian Semiconductor Equipment Associates, Inc.  
Inventors: Charles M. McKenna et al.  
Art Unit: 2881

**STATEMENT UNDER 37 CFR § 1.324(b)(2) REGARDING CHANGE OF INVENTORSHIP**

Sir:

I, **DOUGLAS A. BROWN**, state that I have no disagreement to the requested change of inventorship in adding Manny Sieradzki as an inventor in the above-referenced patent.

Respectfully submitted,

Date: 11 October 2007 By: Douglas A. Brown  
Douglas A. Brown

Docket No. 99-005  
Express Mail: EM 083176878 US

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Patent No.: 6,998,625  
Issue Date: February 14, 2006  
Title: Ion Implanter Having Two-Stage Deceleration Beamline  
Assignee: Varian Semiconductor Equipment Associates, Inc.  
Inventors: Charles M. McKenna et al.  
Art Unit: 2881

**STATEMENT UNDER 37 CFR § 1.324(b)(2) REGARDING CHANGE OF INVENTORSHIP**

Sir:

I, **EDWARD BELL**, state that I have no disagreement to the requested change of inventorship in adding Manny Sieradzki as an inventor in the above-referenced patent.

Respectfully submitted,

Date: 8/29/07 By: Edward Bell  
Edward Bell

Docket No. 99-005  
Express Mail: EM 083176878 US

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

Patent No.: 6,998,625  
Issue Date: February 14, 2006  
Title: Ion Implanter Having Two-Stage Deceleration Beamline  
Assignee: Varian Semiconductor Equipment Associates, Inc.  
Inventors: Charles M. McKenna et al.  
Art Unit: 2881

**STATEMENT UNDER 37 CFR § 1.324(b)(2) REGARDING CHANGE OF INVENTORSHIP**

Sir:

I, **SVETLANA RADOVANOV**, state that I have no disagreement to the requested change of inventorship in adding Manny Sieradzki as an inventor in the above-referenced patent.

Respectfully submitted,

Date: 8/28/07

By: Svetlana Radovanov  
Svetlana Radovanov